

# Probe Measurements of Electrostatic Fluctuations in LDX

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Plasma Physics*

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# Introduction

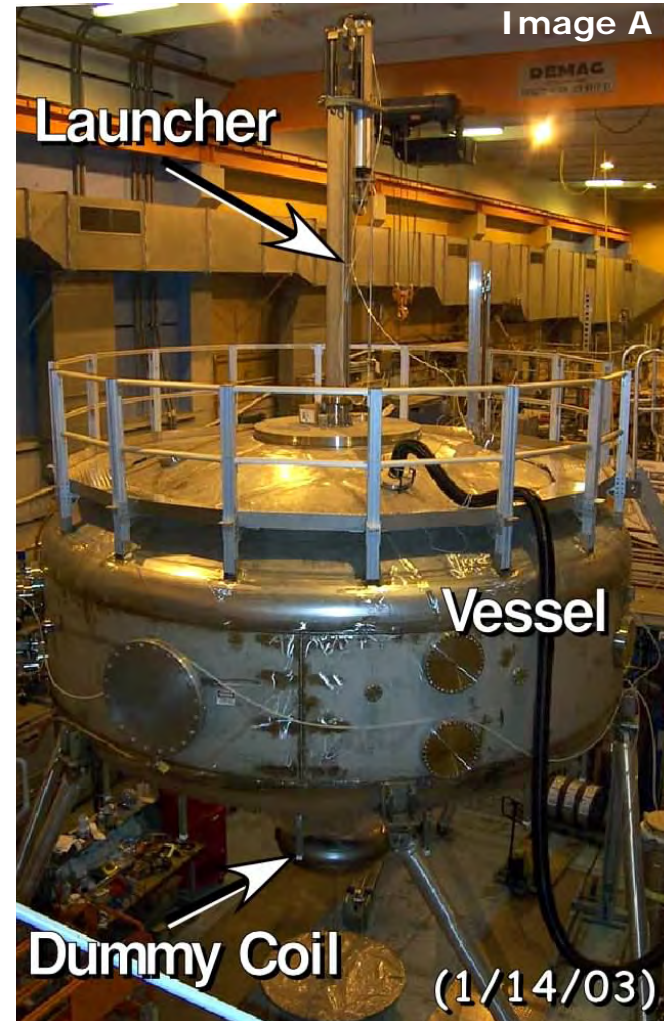
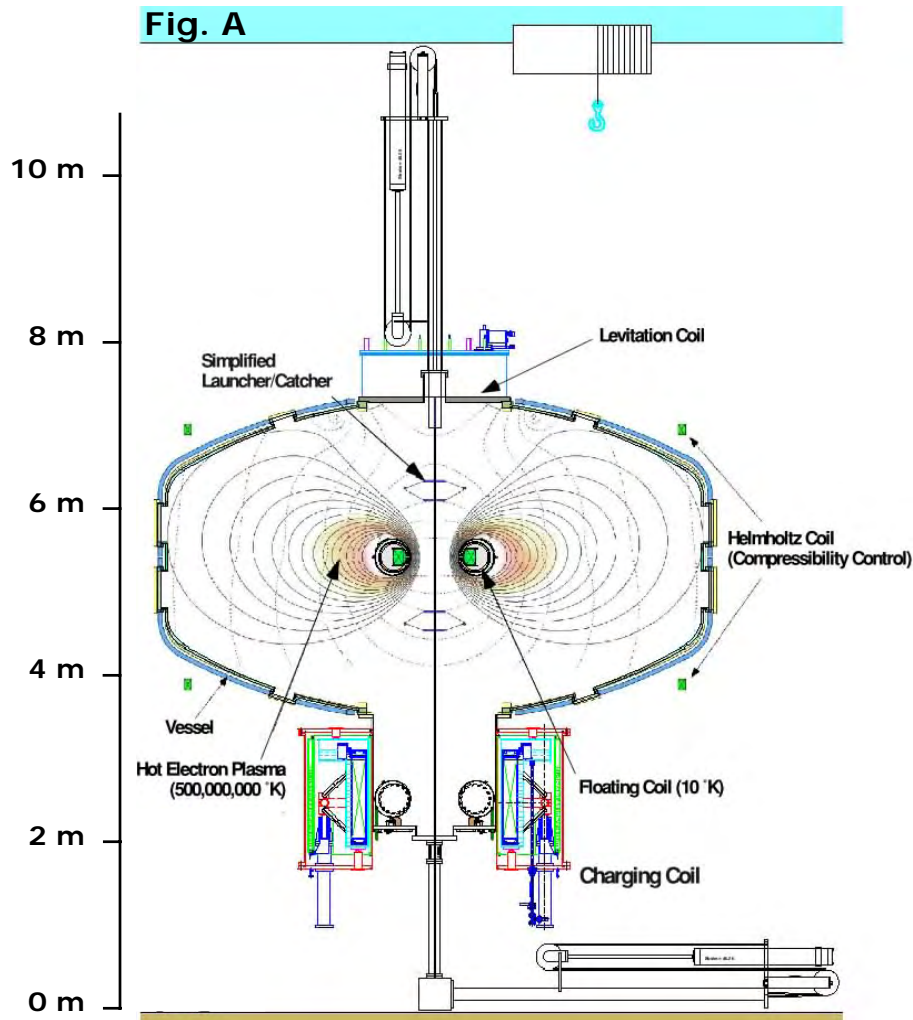
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The first physics experiments were conducted on the Levitated Dipole Experiment (LDX). Two campaigns have been run, one on August 12-13 and the other on September 16-17, with the central floating coil suspended by a launcher/catcher system. The goals of these initial runs were to:

1. demonstrate successful operation of LDX in supported mode
2. create dipole-confined plasma and measure basic parameters using current diagnostics systems
3. investigate plasma heating with single and multiple-frequency ECRH
4. explore plasma response to varying magnetic field and gas pressure
5. identify interesting probe behavior and conditions leading to maximum beta

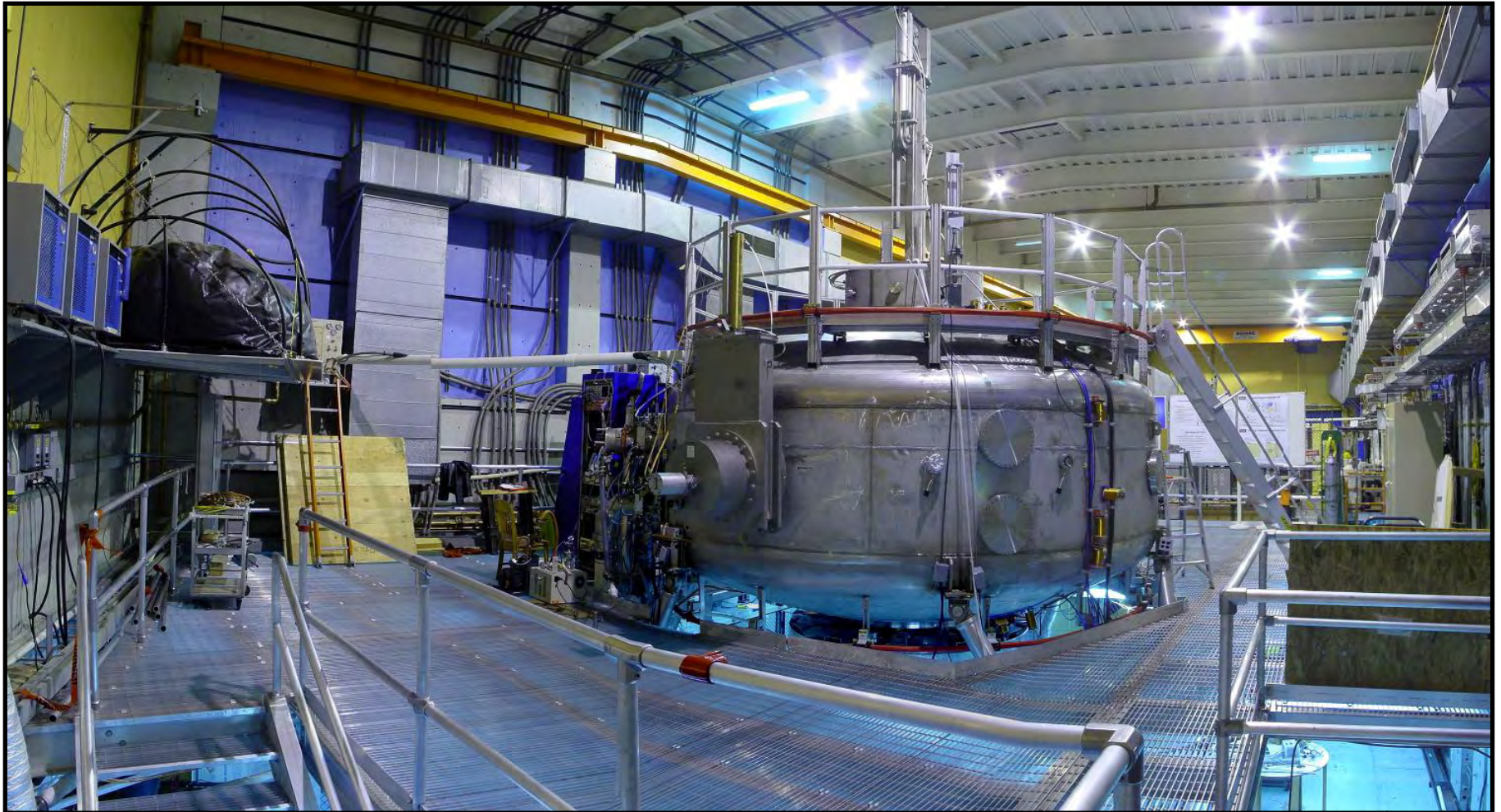


# The Big Picture



# The Bigger Picture (latest picture)

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\* Image by E. Ortiz. Nov 12, 2004.



# LDX Parameters

	EXPECTED <sup>**</sup>	AUG Run <sup>*</sup>	SEP Run <sup>*</sup>
Current in Floating Coil (A)	1,190,000	750,000	900,000
Total Plasma Volume (m <sup>3</sup> )	26	-	-
Core Volume (m <sup>3</sup> )	0.5	-	-
B at Core (G)	47,600	30,000	36,000
B at Edge (G)	50	26	31
Core HOT electron density	3.60E+16	-	-
Core total electron density	7.60E+16	-	-
Core HOT Te (eV)	250,000	40,000	20,000
Core thermal Te (eV)	5,000	-	-
Core thermal Ti (eV)	50	-	-
Peak core Beta (%)	55	3 <sup>+</sup>	8 <sup>+</sup>
Edge Vf during Heating (V)	?	[-28,-24]	[-28,-20]
Edge Density (m <sup>-3</sup> )	[7e14]	[2e15,2e16]	[1e15,1e16]
Edge thermal Te (eV)	5	8	10.5



# LDX Parameters

	Diverted, No Shaping	Diverted, Maximum Beta	Diverted, Minimum Beta	Limited Plasma
Top HelmHoltz (I_top)	0	1	50	3
Bottom HelmHoltz (I_bot)	0	12	50	12
Plasma Volume (m <sup>3</sup> )	14	27	1.7	24
SOL Pressure (Pa)	<b>0.25</b>	<b>0.25</b>	<b>0.25</b>	<b>0.1</b>
Max Pressure (Pa)	136	1530	1530	472
Plasma Current (kA)	3.2	16.4	16.4	5.78
Stored Energy (J)	316	1450	1450	516
R(Pmax)(m)	0.76	0.76	0.77	0.79
B(Pmax)(T)	0.088	0.088	0.088	0.088
Beta(Pmax)	<b>0.08</b>	<b>0.55</b>	0.015	0.15

\*\* Table by D. Garnier. Updated by E. Ortiz. Nov 2004.



# Overview of LDX Probes

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- Current Electric Probes
  - Isat, Vf, Single Swept, Mach
- Data Acquisition System
  - Probe Board Circuitry
  - Digitizers
  - Cabinet/Power Supplies
- Current Data Analysis
  - Swept probe analysis
    - Eliminating capacitive coupling
    - IV curve analysis (Single, Multi, Robust)
    - Multi-probe analysis (Mach probe)
  - Non Swept Probe Analysis
    - Floating & Isat probe considerations



# Overview of LDX Probes cont...

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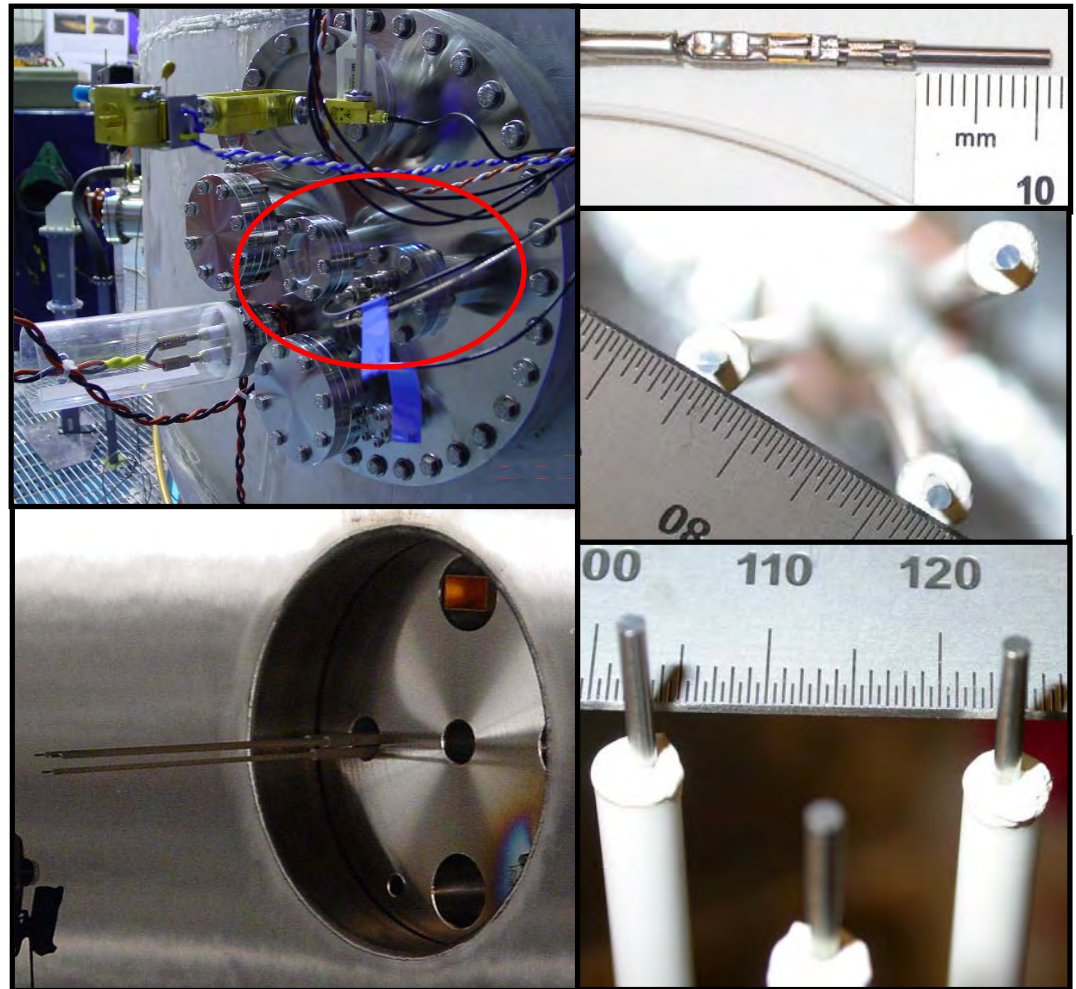
- Langmuir Results
  - Gas Scans
  - Modulated Runs
  - Varying Magnetic Field
  - Varying Gases
- A word on results
  - Vacuum Conditioning (GDC)
- Upgrades
  - New probe designs, layout, and circuitry
    - Triple probe
    - Emissive probe
    - Positioning system
    - Field array?





# Current Electric Probes (Lang)

- Langmuir Probes
  - Three equally sized probes
  - Thoriated tungsten
    - $l = .9922$  cm
    - $d = .1588$  cm
    - $A_s = .4948$  cm<sup>2</sup>
  - Ceramic bond sealant
    - 904 ZIRCONIA, Ultra Hi-temp ceramic adhesive (Cotronics)
  - On mid-plane
    - LHS probe -> Isi
    - RHS probe -> Swept
  - Below mid-plane
    - MID probe -> Vf
  - All probes 1.27 cm apart on mid-plane

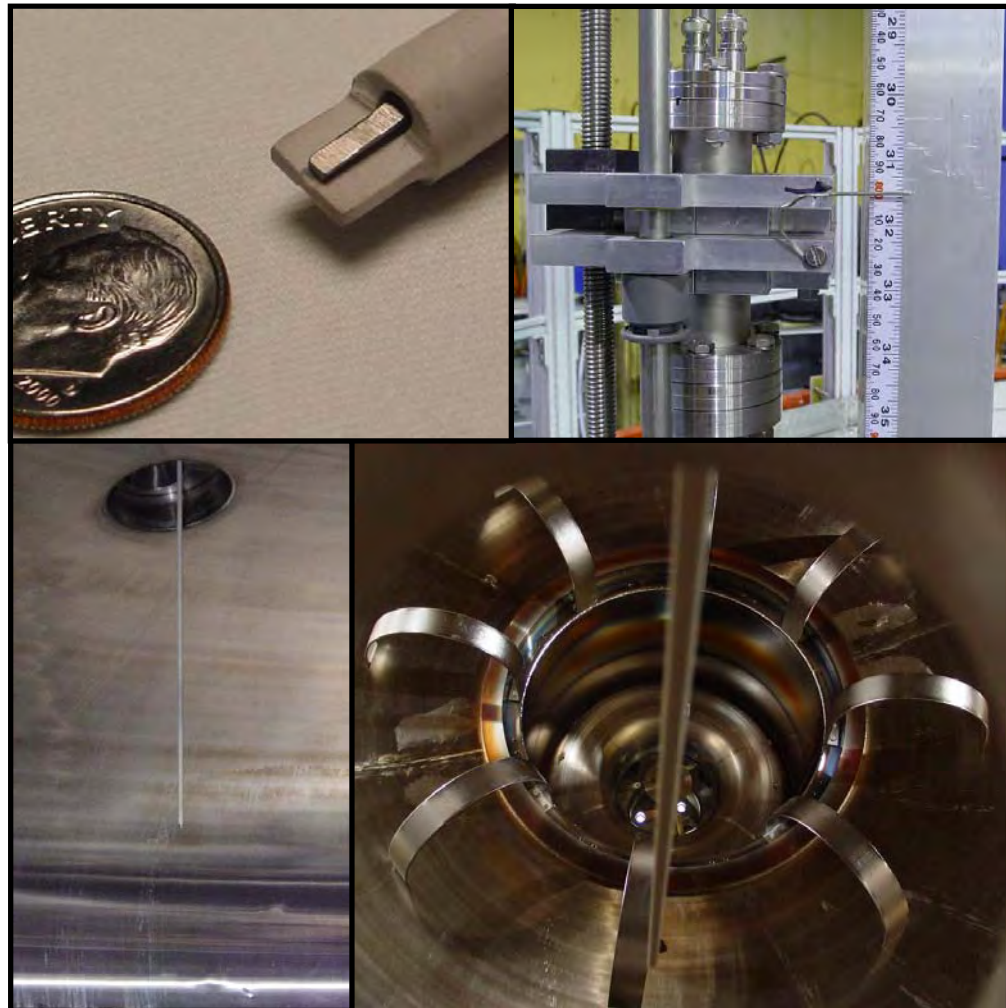


\* Images by E. Ortiz. July 25, 2004. Aug 1..19, 2004. Nov 12, 2004.



# Current Electric Probes (Mach)

- Mach Probe
  - Two equally sized probes
  - Thoriated tungsten
    - $l = .6350$  cm
    - $d = .1588$  cm
    - $As = .1008$  cm<sup>2</sup>
  - // to Z-axis on 1 of 4 top diagnostics port
    - Probes Swept
  - Variable linear motion
  - Maximum penetration ( $\sim 60$  cm) for all experiments
    - See 'Probe Location' below for details
  - Aligned  $\perp$  to B-field



# Probe Interface System



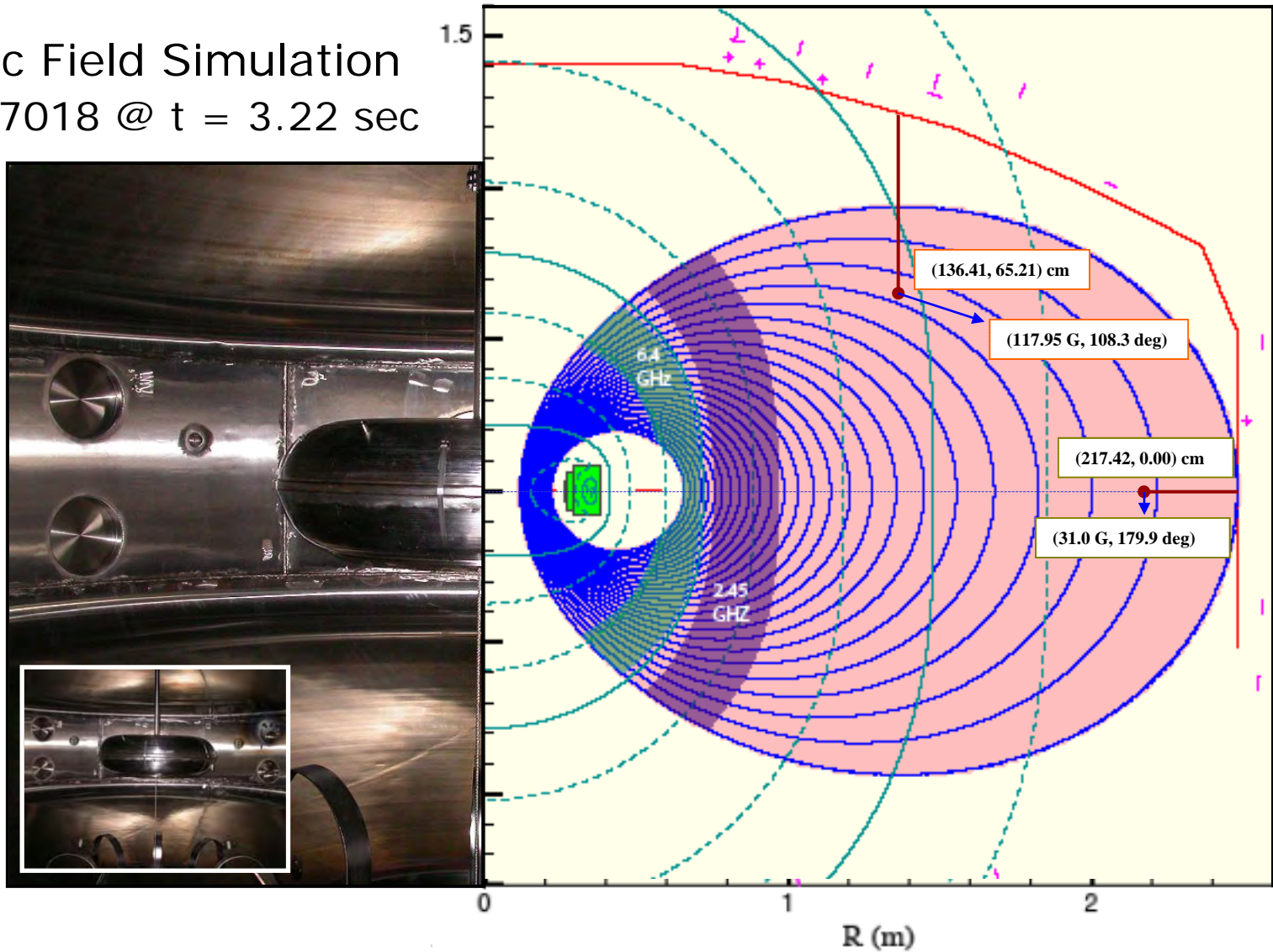
\* Image by E. Ortiz. Nov 12, 2004.

- Easy access via platform
  - Actual height ~ 4.5' (137 cm) from base flange
  - Four ports available
- Bellow stroke ~ 32.5" (83 cm)
  - Max length ~ 42.25" (108 cm)
  - Min length ~ 9.75" (25 cm)
- Linear incursion depth into chamber ~ 60 cm
- Remove probe w/out breaking main vacuum
- Remotely control linear motion with probe position system and air-motors
- Applications
  - Select specific magnetic field lines to probe or bias with emissive probe
  - Retractable GD anode



# Probe Location Relative to Plasma

- Magnetic Field Simulation
  - 40917018 @  $t = 3.22$  sec



EO\_APS\_DPP\_11-04

\*Figure by A.K. Hansen. Edited by E. Ortiz. Nov 03, 2004. Image by E. Ortiz. July 24, 2004.

# Magnetic Field at Probe

	40813032		40917019		
	Top	Side	Top	Side	
Te	13.6	7.0	10.1	9.8	eV
Density	3.69E+16	4.73E+15	2.68E+16	2.92E+15	m-3
B-Field	97.1	26.0	118.0	31.0	Gauss
B-Field Direction	108.6	180.0	108.3	180.0	o from Vert
Cyclotron Freq.	0.3	0.1	0.3	0.1	GHz
Thermal Velocity	1548.2	1108.0	1335.2	987.1	km/s
Gyroradius	5.7	15.2	4.0	11.4	mm
Debye Length	0.143	0.285	0.145	0.324	mm

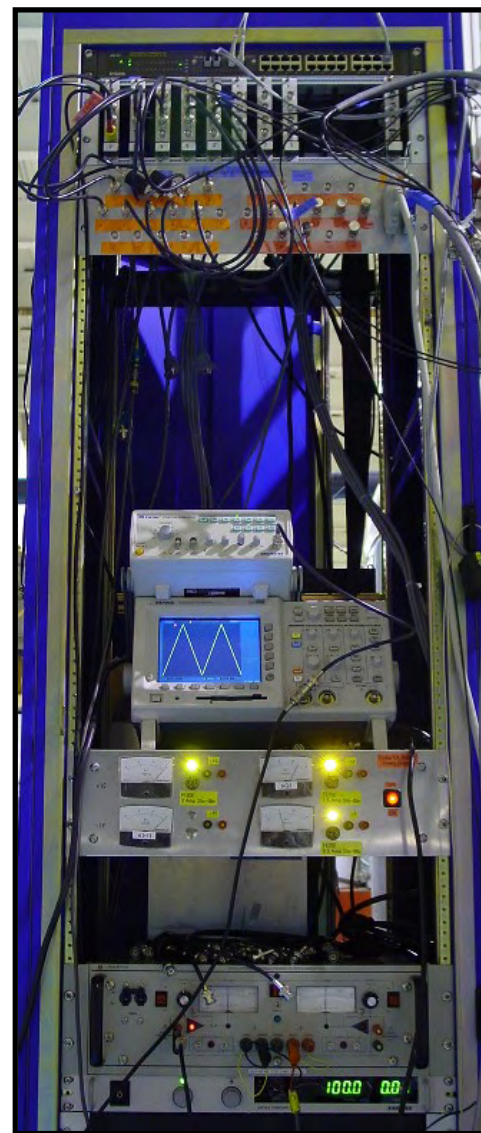
- Designed by ~~...~~ Bombard for ALCATOR plasmas
- Re-designed by ~~...~~ Trulke for LDX plasmas
- 50 boards built with front access, [Pin, Vout, Iout, V<sub>sweep</sub>(3)]
- Flexible design amp ~~...~~ buffers and can be remotely controlled to adjust ~~...~~ settings
  - *Individually Select: V<sub>sweep</sub>, calibration, Float settings*

Text talks about probe design gyro radius etc.



# Cabinet Setup

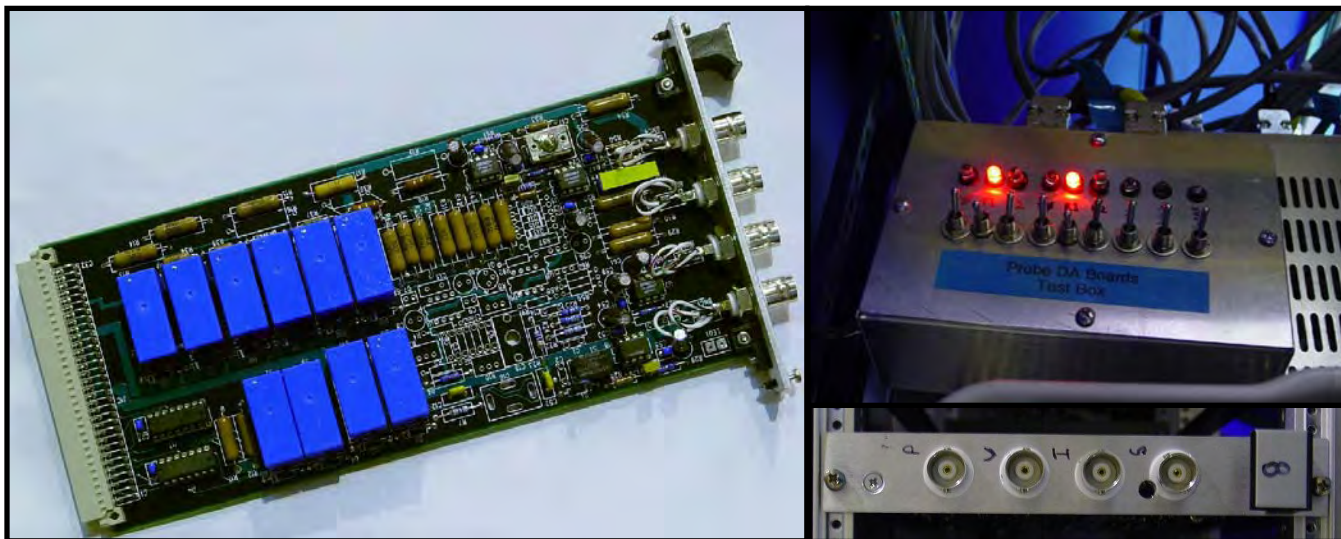
- New magnetically shielded
- Electrically Isolated
- Current Guests:
  - Front
    - Probe Ckt boards housing box
    - Digitizer breakout panel
      - Waveform Generator
      - Scope
    - Probe Ckt board PS
    - High Voltage Sweeping PS
    - Stable High Voltage PS
    - Probe board switch box (not visible)
    - RGA Controller
    - Interferometer control box
  - Rear
    - Probe positioning PLC
    - Optical encoder PS
- Future Guests:
  - Emissive PS
  - Triple probe Ckt Box



\* Image by E. Ortiz. Nov 12, 2004.



# Probe Ckt Boards and Control

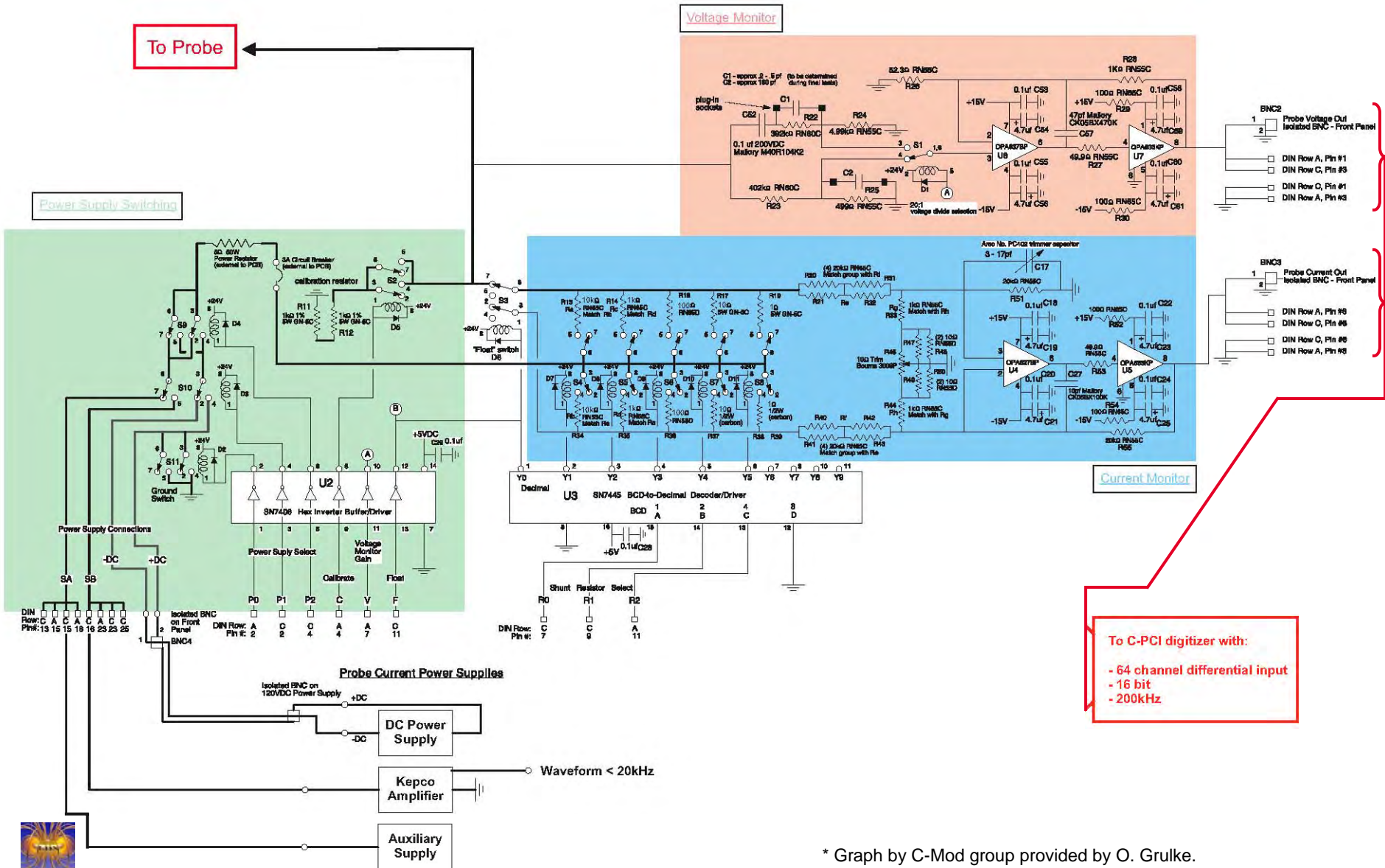


\* Images by E. Ortiz. Nov 12, 2004.

- Designed by Brian LaBombard for ALCATOR plasmas
- Re-designed by Olaf Grulke for LDX plasmas
- 50 boards built with easy front access, [Pin, Vout, Iout,  $V_{sweep}(3)$ ]
- Flexible design amplifies, buffers and can be remotely controlled to adjust various settings
  - *Individually Select:  $V_{sweep}$ ,  $R_{load}$ , Calibration, Float settings*



# Sweep Probe Board Circuit

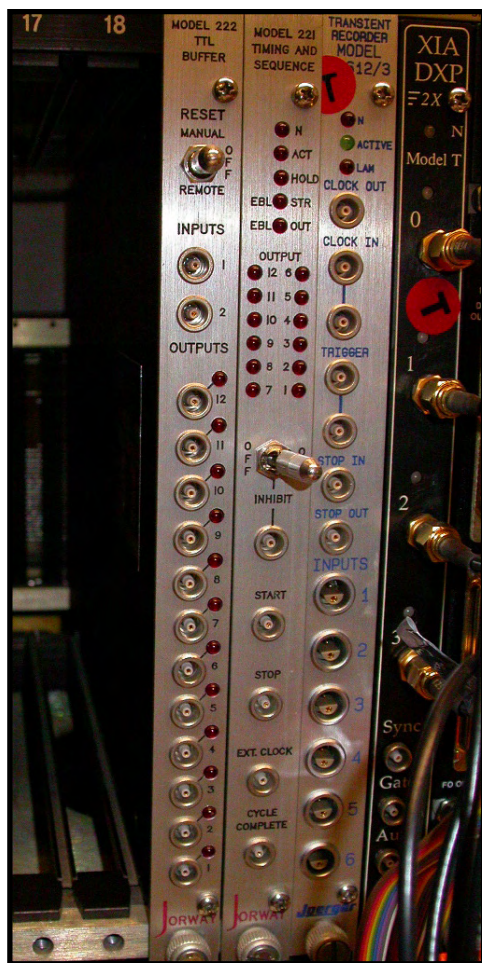


\* Graph by C-Mod group provided by O. Grulke.





# Digitizer Boards



\* Image by E. Ortiz. June 6, 2004.

- (1)-Joerger 612/3 Transient Recorder/Digitizer
- 6 channels, 12 bit resolution, 3 MHz sample
- Input impedance ~ 1 M $\Omega$  differential, CAMAC
- Input range  $\pm 5$  V shipped,  $\pm 10$  switch able



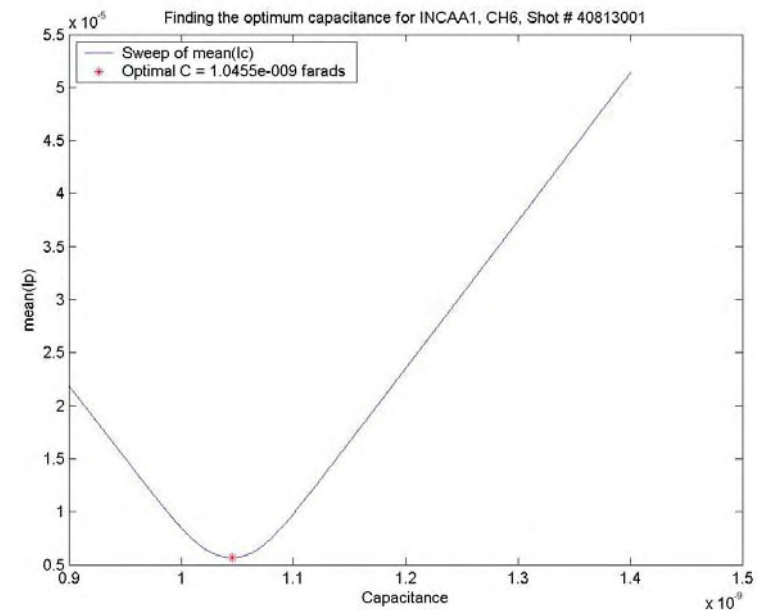
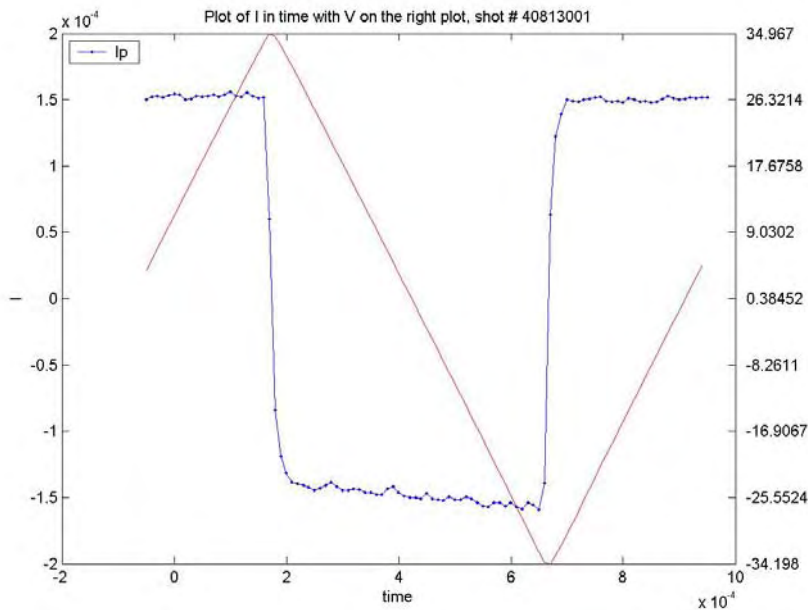
\* Image by E. Ortiz. June 6, 2004.

- (4)-Incaa CP-TR10-5020 Isolated Transient Recorder, CPCI
- 16 channels, 16 bits, 200 KS/s sample
- Input range  $\pm 10$  V
- Input impedance ~ 800 k $\Omega$  differential
- Accuracy  $\pm .05\%$  of full scale for both



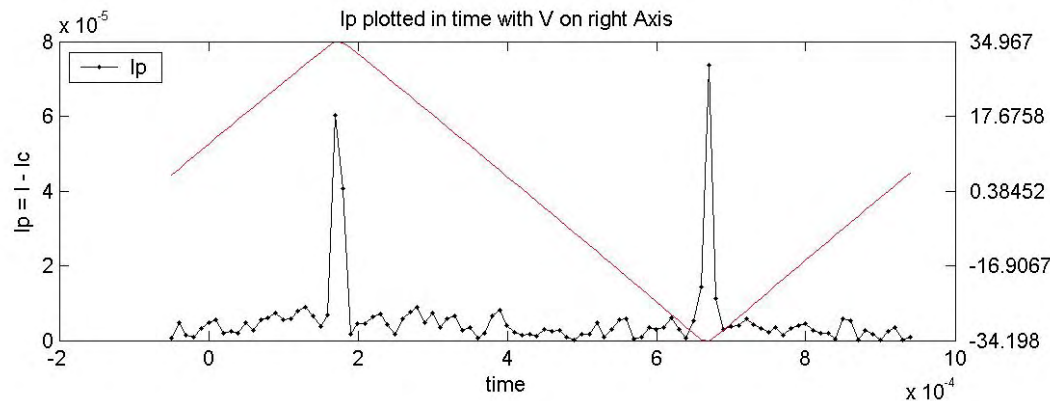
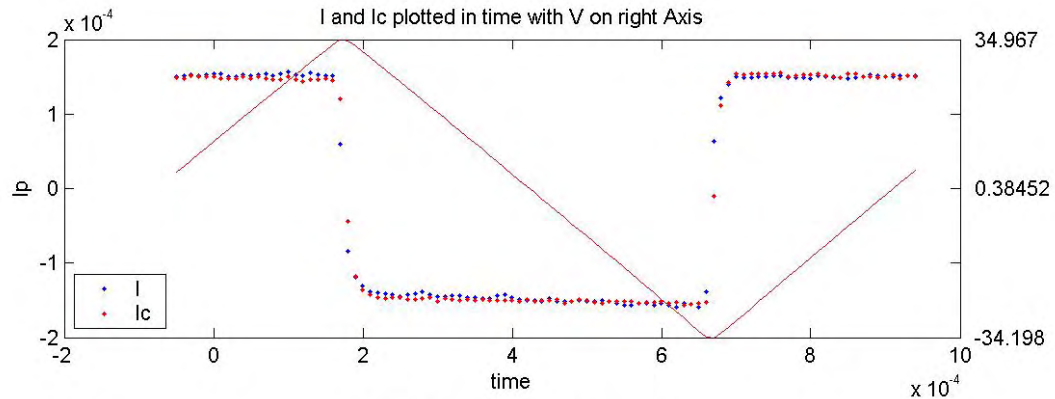
# Data Analysis – Initial Considerations

- Langmuir probes known for capacitive currents from the sweeping voltage
  - Important to subtract out this current
  - $I = I_c + I_p$ , where  $I_c = c * dV/dt$
  - Find  $c$  by recursive fitting



# Data Analysis – Initial Considerations

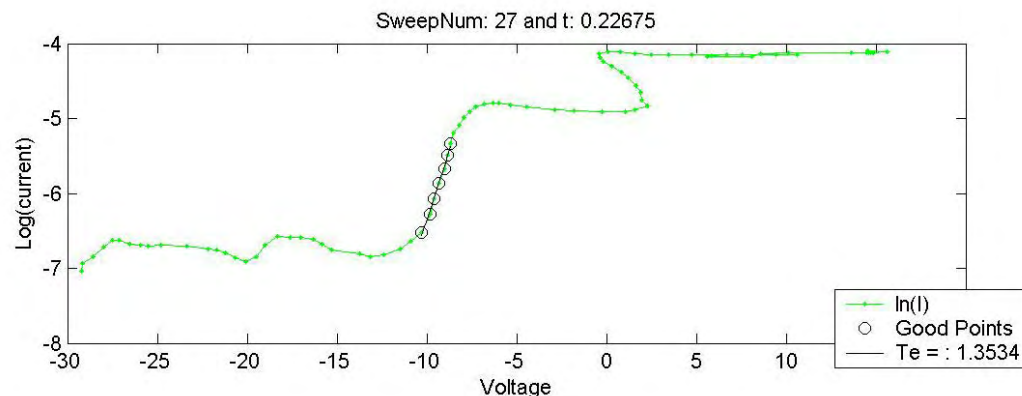
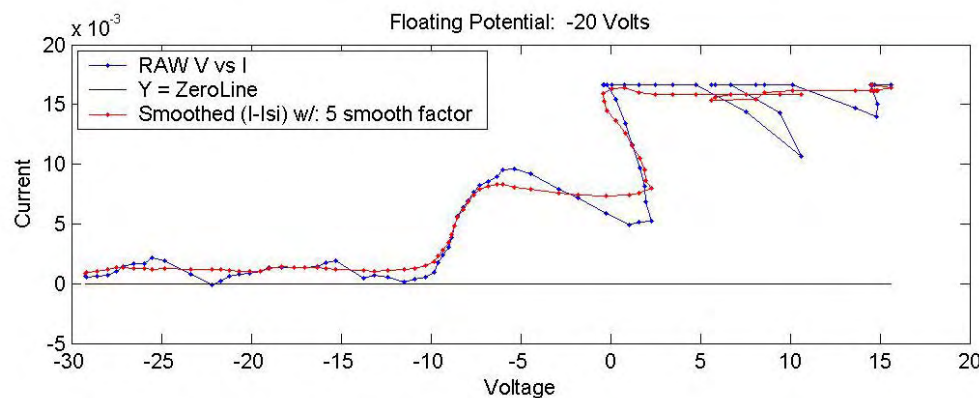
- ‘On the fly’ correction of  $I_p$ , independent of shot & channel
  - Take pre-trigger (ie pre-plasma) data and find  $C_{\text{shot,channel}}$
  - Obtain  $I_p$  using analysis above
  - Ignore couple points on either side of  $V_{\text{sweep}}$  peaks



# Data Analysis – Sweeping

## How to fit the best characteristic? – One by One

- Not all IV curves are created Equal!
  - Expect Ion Sat, Characteristic, and Electron Sat regions
  - Sweeping Frequency matters - # points per sweep
  - Assume Maxwellian distribution of electrons and obtain  $T_e$  and from Transition region



- IV Analysis Formalism:
  - Take (1) sweep
  - Smooth (5) & choose  $I_{si}$  as  $\min I_p$
  - Subtract and take log
    - $\ln(I_p - I_{si})$
  - Find "Good" points\*
  - Slope  $\sim 1/T_e$
  - No  $\sim I_{si}/\sqrt{T_e}$

Shot # 40917013  
 Sweep Freq = 750 Hz  
 Time = .22675,  $T_e = 1.4$  eV

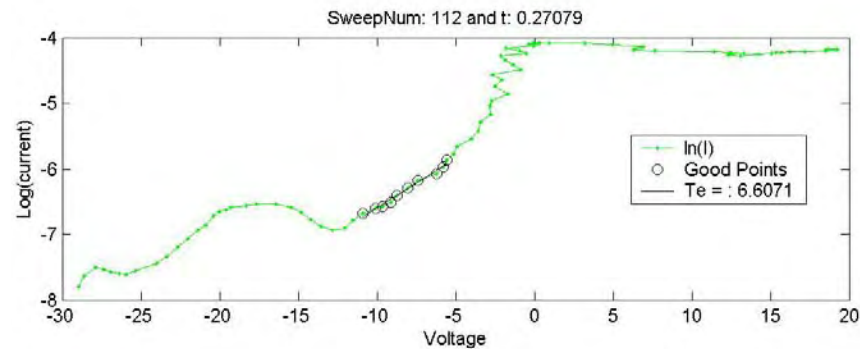
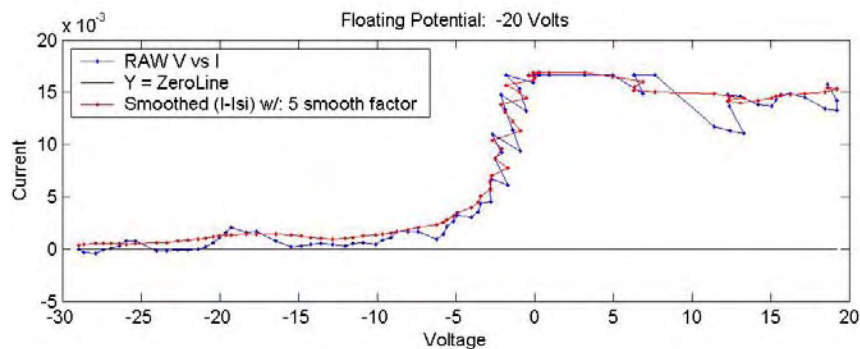


# Data Analysis – Sweeping

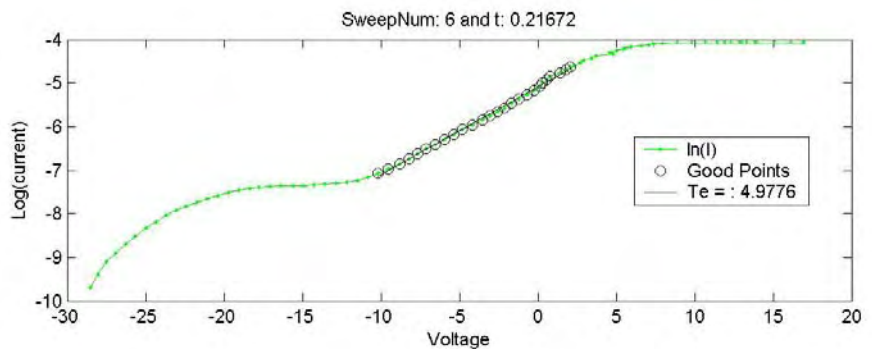
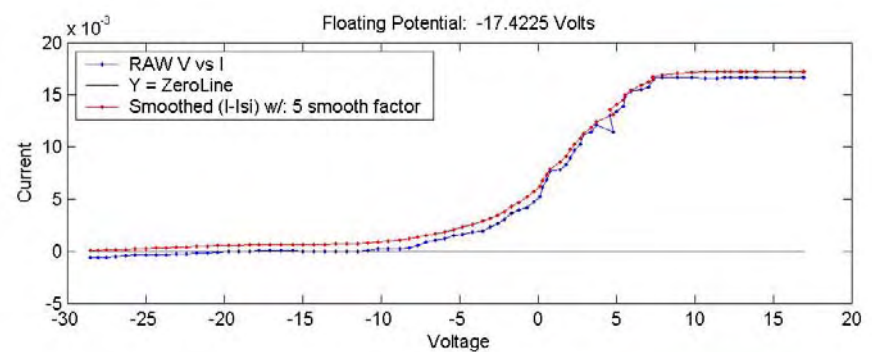
## How to fit the best characteristic? – One by One

- Smooth out the function and obtain  $I_{si}$  as smallest value of  $I_p$  of sweep
- Same Shot (40917013)
- LHS a complete mess, RHS as IV's are supposed to look

Time = .27029,  $T_e = 6.6$  eV



Time = .21672,  $T_e = 4.9$  eV



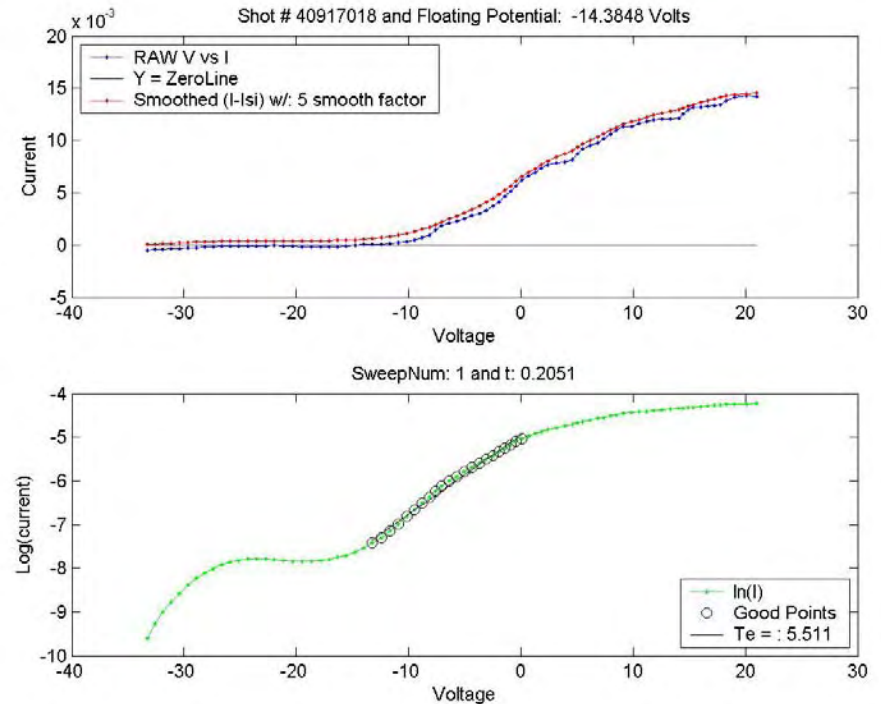
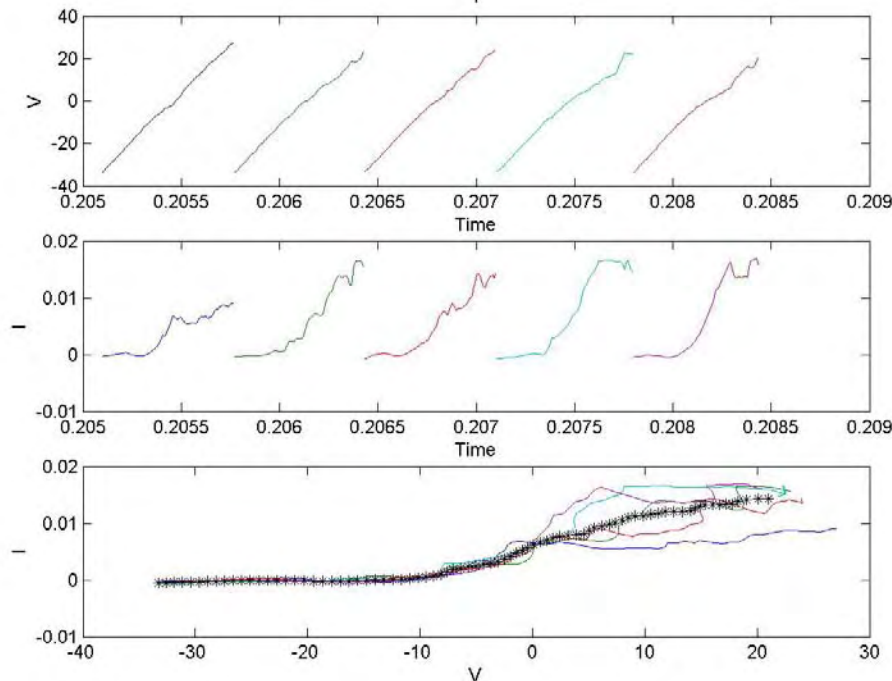
# Data Analysis – Sweeping

## How to fit the best characteristic? – Five at a Time?

- We can also try fitting sets or multiple sweeps (Multi)
  - Take a series (say five) consecutive IV plots
  - Take an average of them
  - Then find the slope as before

Time = .205-.208

Te = 5.5 eV

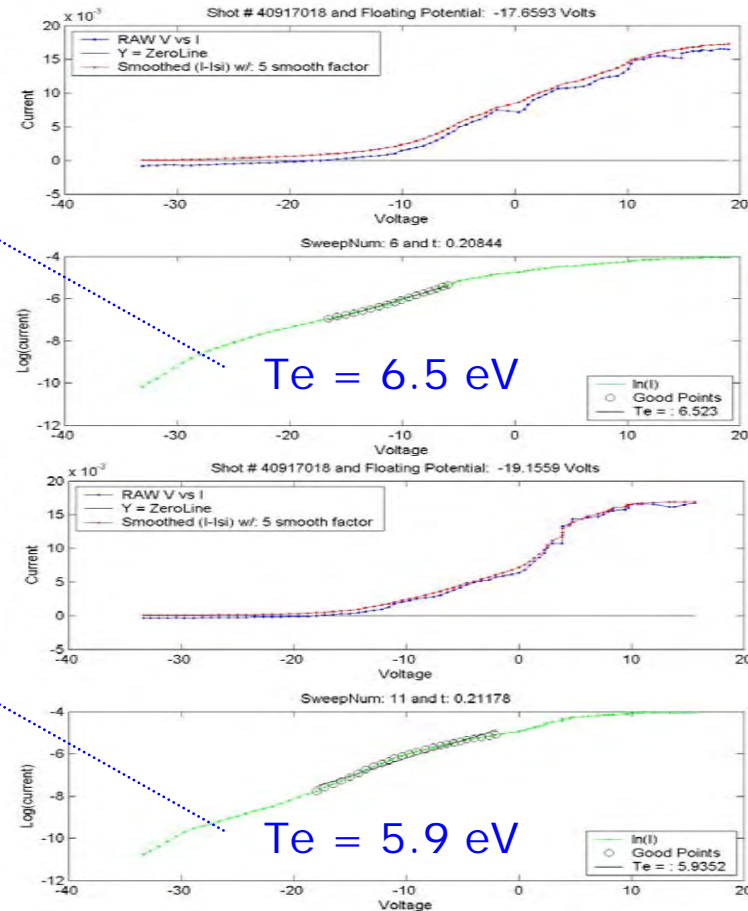
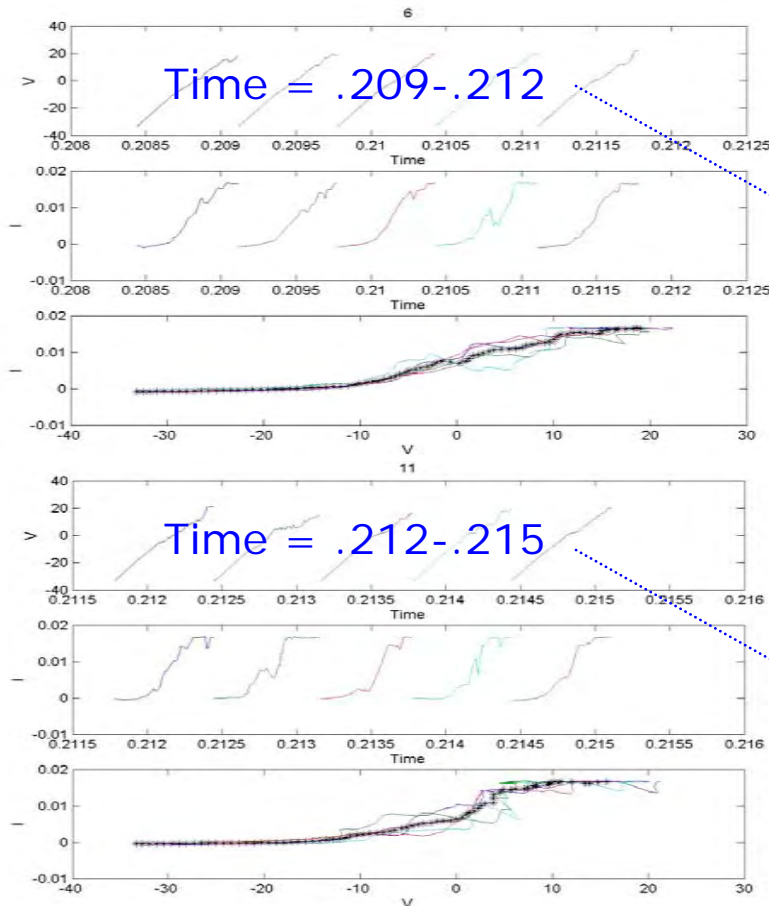


- A couple more examples...



# Data Analysis – Sweeping

## How to fit the best characteristic? – Five at a Time?



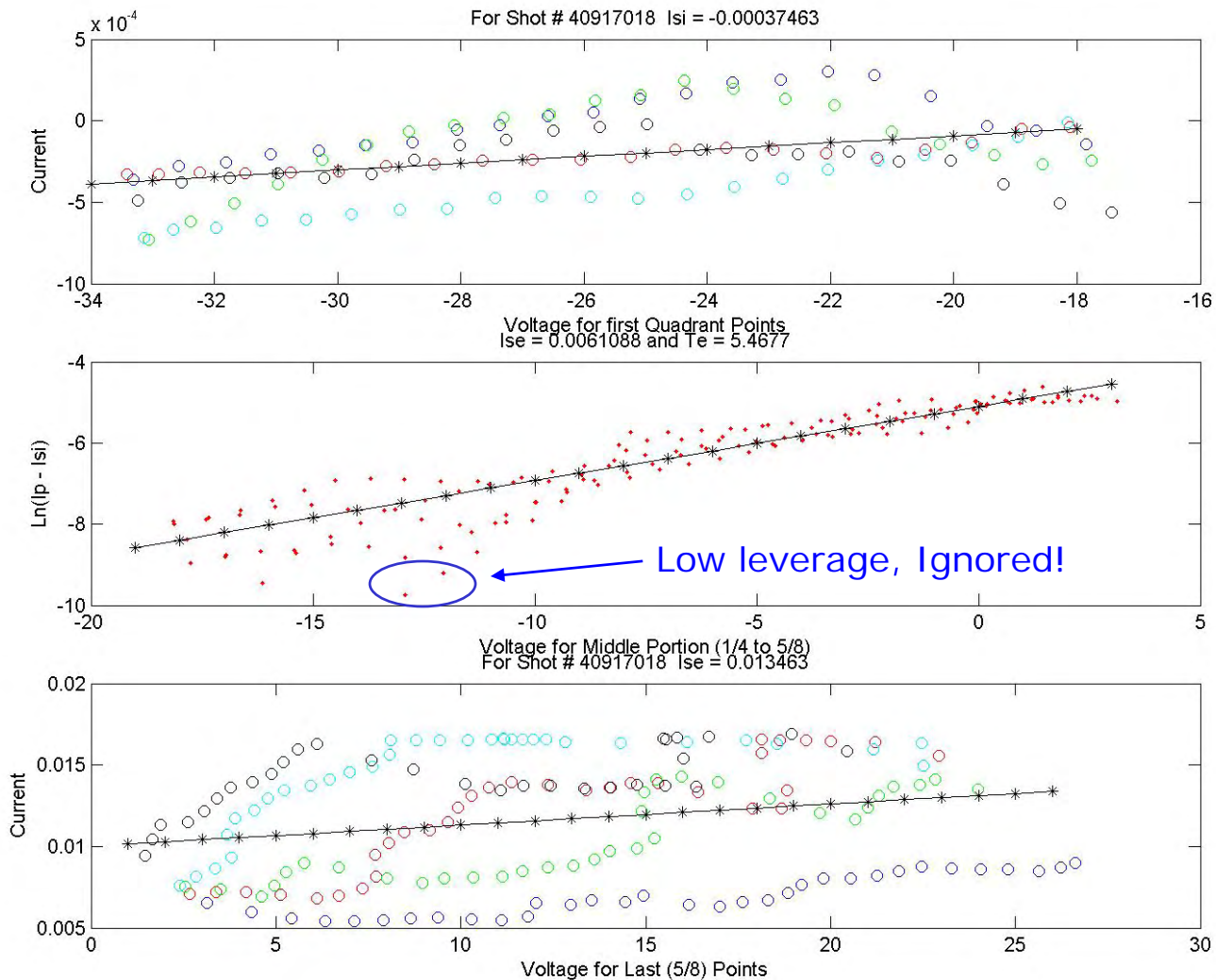
- Results show/prove that taking multiple sweeps helps
  - Why not take more? ... in fact for 750 Hz, 25X arrived trial/error
  - Not exact science since  $V_{sp}$  changes in time – should shift in time
  - What about outliers? ...S/N ratio reduced but is it real?



# Data Analysis – Sweeping

## How to fit the best characteristic? – Robust Fitting

- Robust fitting gives us the best of both worlds...
  - Filter out outliers and average over multiple sweeps!



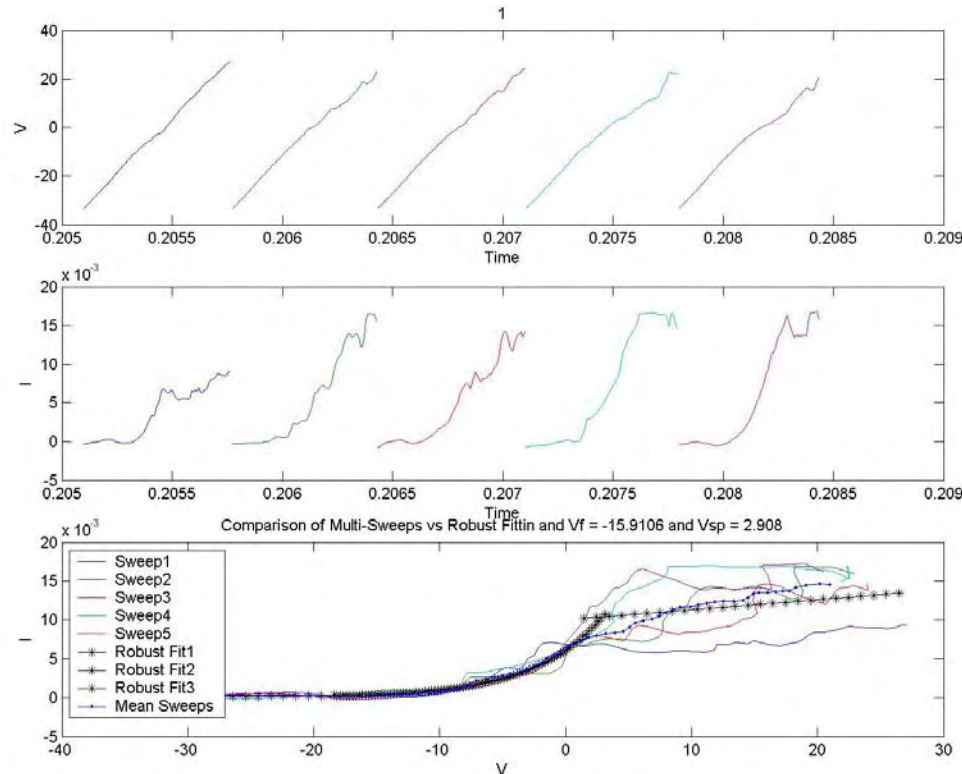


# Data Analysis – Sweeping

## How to fit the best characteristic? – Robust Fitting

- Robust fitting tends to report higher values of  $T_e$  than other methods
  - For Same Shot (40917018)
  - $T_e(\text{Single}) = 3.3 \text{ eV}$ ,  $T_e(\text{Multi}) = 5.5 \text{ eV}$ ,  $T_e(\text{Robust}) = 8.3 \text{ eV}$

Time = .205-.208 .....  $T_e = 8.3 \text{ eV}$



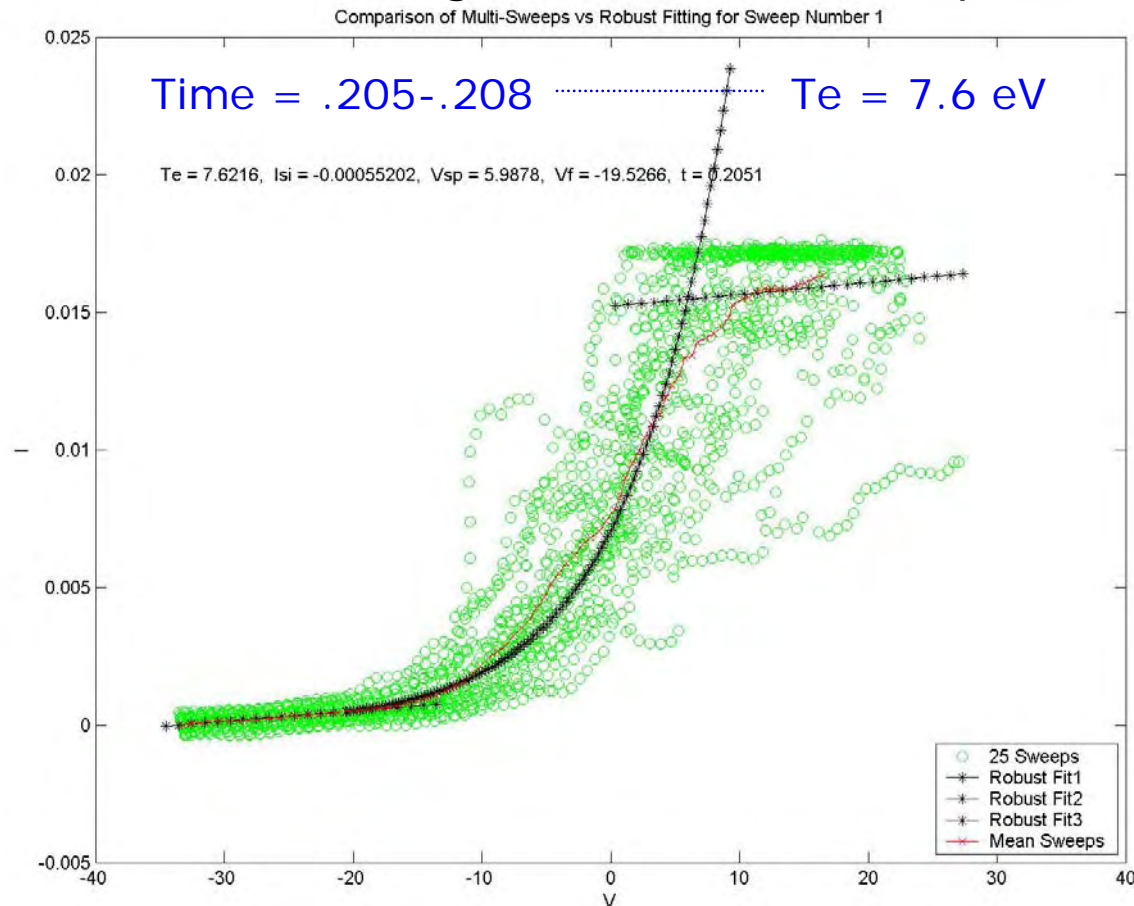
- Robust Analysis Formalism:
  - Determine IV regions
  - Robust fit  $I_{si}$  region
    - $I_{si} = I_{fit}(V_{min})$
  - Subtract  $I_{si}$  and take log in *Transition* region
    - Obtain  $V_f, T_e$
  - Robust fit  $I_{se}$  region
    - Obtain  $V_{sp}$  from log of both *Transition* & *Ise* regions
  - Find  $N_o$  using  $T_e, I_{si}$



# Data Analysis – Sweeping

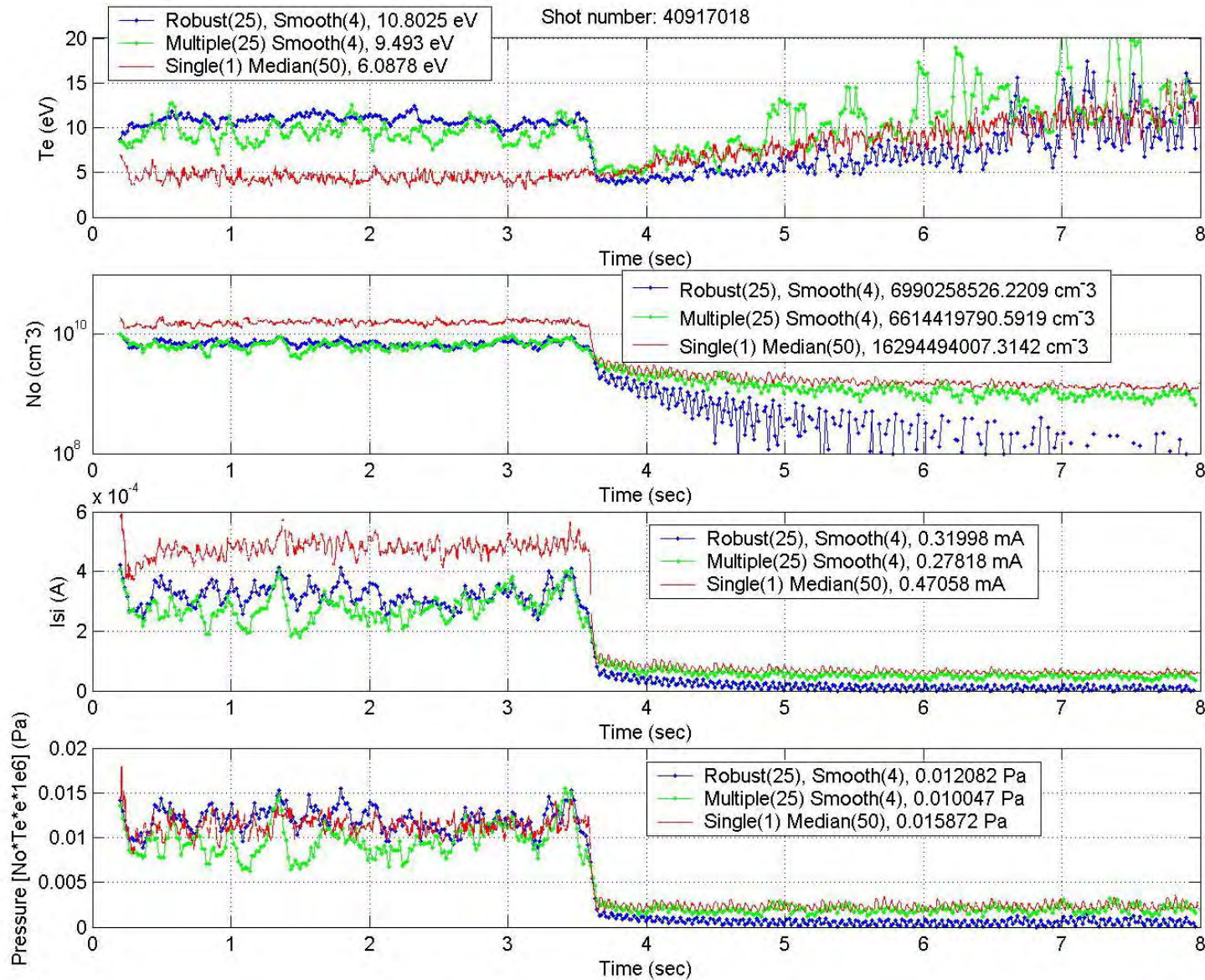
## How to fit the best characteristic? – Robust Fitting

- Robust fitting using 25X
  - Distinction between three regions
  - Notice how Robust avoids outliers and how Multi(red) is pulled up by them in Transition region
  - Even lower  $T_e$  with higher number of sweeps



# Data Analysis – Sweeping

## What is the best method to analyze IV characteristics?



# Data Analysis – Sweeping

## What is the best method to analyze IV characteristics?

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- Summary of Behavior
  - Multiple Sweep Fitting returns higher  $T_e$  during ECRH heating & lower  $T_e$  in the afterglow region
  - MSF gives  $n_e$  &  $I_{si}$  (&  $N_o$ ) in both regions, since  $N_o \sim I_{si}/\sqrt{T_e}$
  - Yet, MSF Pressure is not very different in heating region but lower in afterglow regions
- Discussion

*Fill in later*



# Data Analysis - NonSwept

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IF ENOUGH TIME INCLUDE  
Floating and Isat Probe considerations  
Isi, Vf, fft Spectrum of most interesting CASE  
(40917018?)  
Can do spectral fft



# Results - Gas Scan

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*Analysis Done,  
Past Graphs Saturday*



# Results - Modulated Runs

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*Analysis Done,  
Past Graphs Saturday*



# Results - Varying Magnetic Field

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*Analysis Done,  
Past Graphs Saturday*





# Results - Varying Gases

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*Analysis Done,  
Past Graphs Saturday*



# A word on results...

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*Analysis Done,  
Past Graphs Saturday*



# Vacuum Chamber Condition

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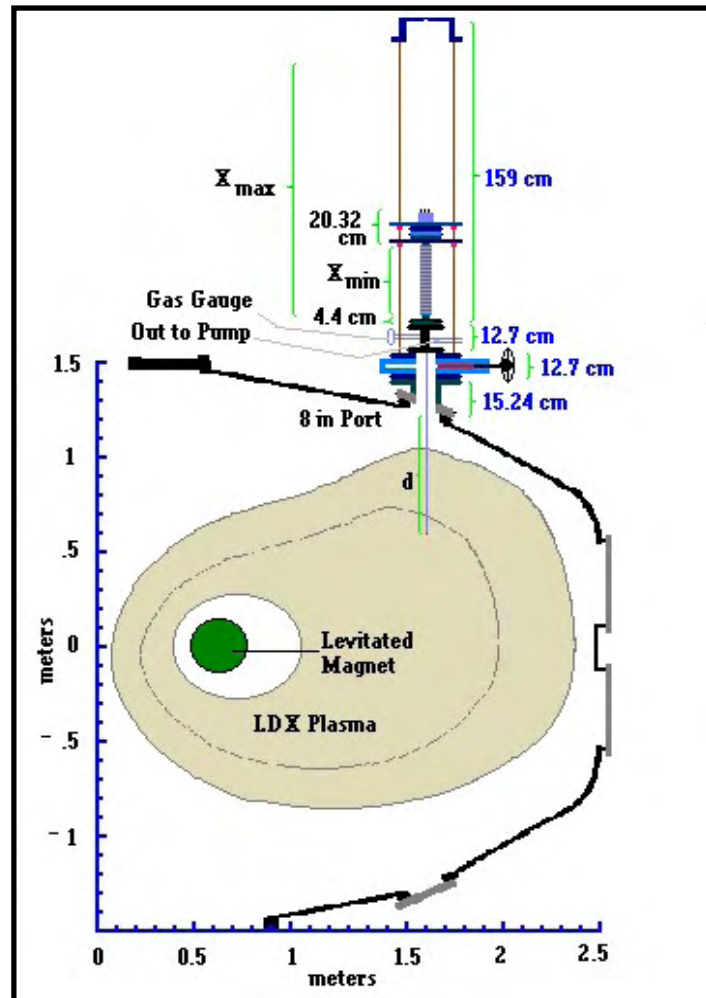
Discuss Quality of Vacuum during first exp.

Again, Analysis done, paste graphs **Sunday**  
**(LAST IF TIME)**

Point out need to have clean environment  
For next run, refer to GDC slides/presentation



# Future Plans & Upgrades (Emissive Probe)



- Measure edge plasma phenomena
  - Fluctuations in local potential, ie. **E**-field
- Switch application to emitting filament and bias single magnetic field line
  - Pin point injection of hot electrons
  - Attempt to 'stir' plasma and create vortex motion
  - Expect density profile evolution (local flattening) - product of particle transport by convective cells [8]

\* Fig. by E. Ortiz. May 15, 2001.



# Future Plans & Upgrades (Triple Probe)

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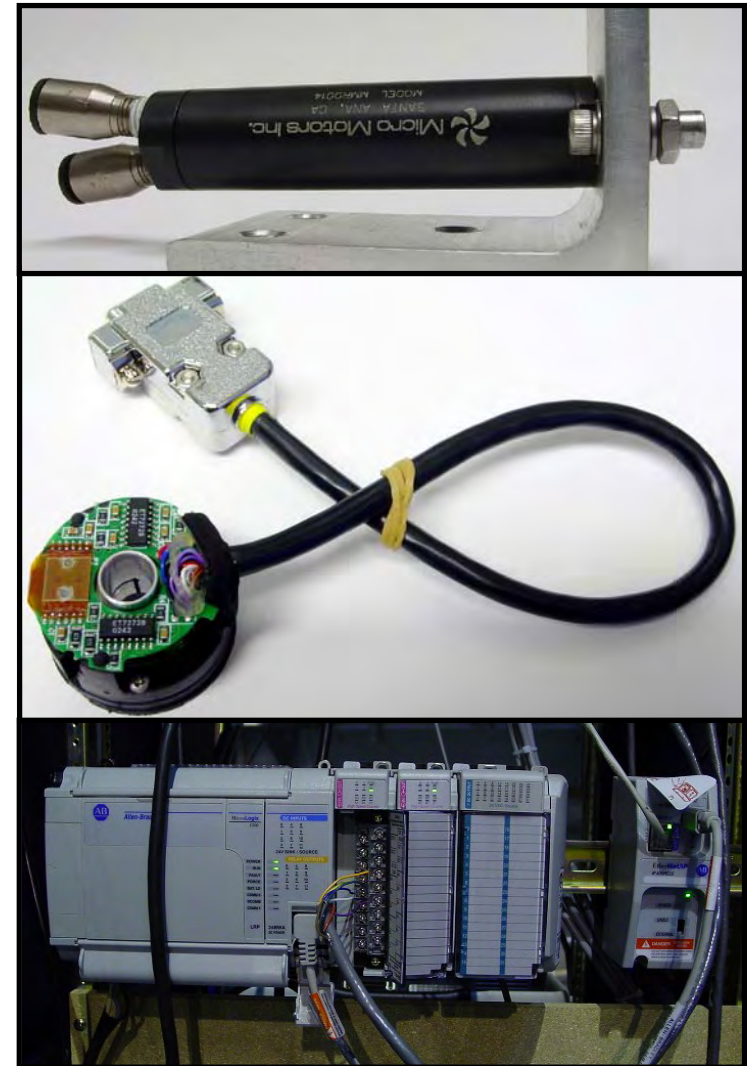
- Triple probe
  - Allow for the instantaneous measurement of electron temperature and density
  - Three electron wires aligned with plasma flow
  - Essential to have three probes as identical as possible and free of contamination

*Talk failure, New design and attach Ckt diagram Saturday*



# Future Plans & Upgrades (Positioning System)

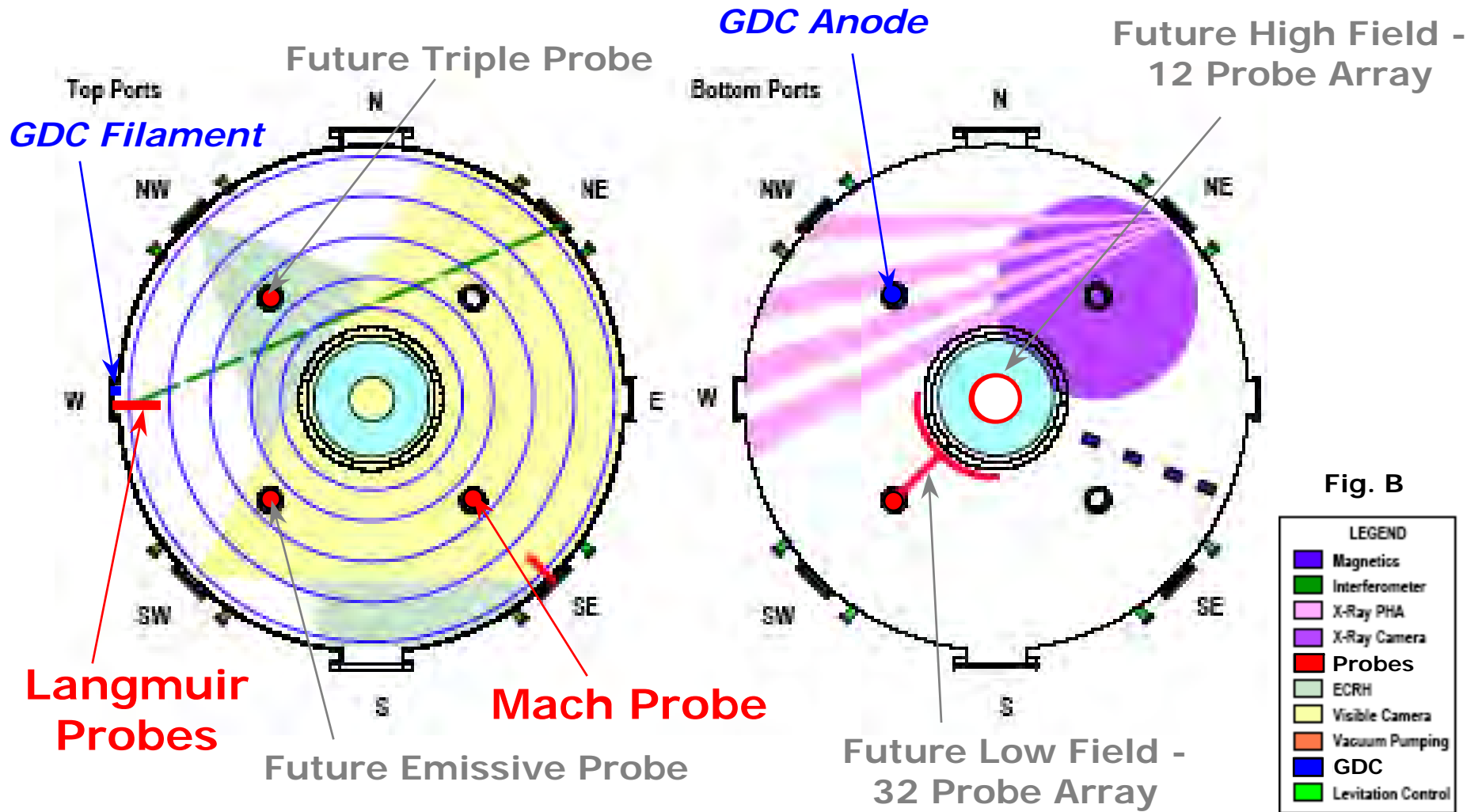
- Dynapar Series M15 1000 PPR modular encoder
- MicroLogix 1500 PLC
  - Compact High Speed Counter module
  - Monitors number of turns of lead screw
- Air motor controlled with PLC feedback loop and solenoid valves
- Will integrate this system into the shot initialization procedure
  - Probes repositioned before each shot



\* Images by E. Ortiz. Nov 12-13, 2004.



# Future Plans & Upgrades (Multi-Probe Array)



\* Figure by D. Garnier. Update by E. Ortiz. Nov 12, 2004.



# Summary

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- Future plans
- Something about Results
- CONCLUSION ON PROBE TYPE, SIZE, include errors in ... too small

Once entire presentation complete  
ADD new TEXT





# Abstract (updated)

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Electrostatic fluctuations play an important role in the equilibrium and stability of a high-beta plasma confined in a dipolar magnetic field. Initial plasma experiments in LDX will use movable edge probes to measure plasma potential, plasma characteristics, and plasma mass flow. Three different probes have been built out of 2 % thoriated tungsten wire and installed: a set of three Langmuir probes [ $l = 1.00$  cm,  $d = 0.16$  cm], an emissive probe [ $l = 1.00$  cm,  $d = 0.02$  cm], and a Mach probe [ $l = 0.64$  cm,  $d = 0.16$  cm]. The emissive and Mach probes are mounted on an adjustable feedthroughs capable of scanning for plasma parameters along a 20-40 cm cord at the plasma edge, but were fixed at a position of (136 cm, 65 cm) relative to the center of the chamber . The Langmuir probes are fixed on the mid-plane penetrating 31 cm from the wall. Initial measurements and interpretations from first plasma experiments will be presented as well as a discussion on the performance of the various probes.

